



## UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE  
 United States Patent and Trademark Office  
 Address: COMMISSIONER FOR PATENTS  
 P.O. Box 1450  
 Alexandria, Virginia 22313-1450  
 www.uspto.gov



Bib Data Sheet

CONFIRMATION NO. 6433

SERIAL NUMBER 10/721,260	FILING DATE 11/26/2003  RULE	CLASS 438	GROUP ART UNIT 1765	ATTORNEY DOCKET NO. TAI 145
-----------------------------	---------------------------------------	--------------	------------------------	-----------------------------------

## APPLICANTS

Toyokazu Sakata, Tokyo, JAPAN;

\*\* CONTINUING DATA \*\*\*\*\* NONE (✓)

\*\* FOREIGN APPLICATIONS \*\*\*\*\* YES (✓) LV  
 JAPAN 2003-149057 05/27/2003

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 03/11/2004

Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance	STATE OR COUNTRY JAPAN	SHEETS DRAWING 3	TOTAL CLAIMS 15	INDEPENDENT CLAIMS 3
Verified and Acknowledged	Examiner's Signature: Initials: LV				

## ADDRESS

23995  
 RABIN & Berdo, PC  
 1101 14TH STREET, NW  
 SUITE 500  
 WASHINGTON, DC  
 20005

## TITLE

Etching method and semiconductor device fabricating method

FILING FEE  RECEIVED 770	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue )
-----------------------------------	---	--